

## Antropov Dmitriy S. Course Schedule

### WEDNESDAY

10:15 — 11:50	▣	LEC	Thermal fields in the device engineering, thermal exposure and testing	👥 M18-621	📍 VNIIA
	▣	SEM	Thermal fields in the device engineering, thermal exposure and testing	👥 M18-621	📍 VNIIA
11:55 — 13:30	■	SEM	Thermal fields in the device engineering, thermal exposure and testing	👥 M18-621	📍 VNIIA